IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Masashi OZAWA et al. Conf. 2595

Application No. 10/534,155 Group 2813

Filed November 7, 2005 Examiner David S. Blum

ELECTROLYTIC CAPACITOR MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in an Official Action. A copy of the Japanese Official Action in which they were cited is attached hereto, with an English translation.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

The petition fee of \$180 required by 37CFR 1.17(p)was electronically paid.

Respectfully submitted,

YOUNG & THOMPSON

Robert J. Patch, Reg. No. 17,355

209 Madison Street, Suite 500

Alexandria, VA 22314

Telephone (703) 521-2297

Telefax (703) 685-0573 (703) 979-4709

RJP/dmw

January 7, 2009